

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/725,788	LI ET AL.	
Examiner	Art Unit	
Jean B. Corrielus	2637	

SEARCHED				
Class	Subclass	Date	Examiner	
375	130;140	11/18/2005	JBC	
	144;147	-		
	148;142			
	150;349			
	267;347			
	346;285			
		:		

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
375	130;140	3/11/2006	JBC		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
East	11/18/2005	JBC	
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